



#10/a
2/26/3
Surles

Filed Via Express Mail pursuant to 37 C.F.R. 1.10

Rec. No.: EL 096 406 889 US

On: FEBRUARY 14, 2003

By:

LINDA E. HASTINGS

Any fee due as a result of this paper, not covered by an enclosed check, may be charged on Deposit Acct. No. 50-1290.

Attorney Docket No.: NECF 18.591

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: Takaaki NAGAI

Serial No.: 09/837,734

Filed: April 17, 2001

Title: **NON-VOLATILE SEMICONDUCTOR STORAGE
APPARATUS AND MANUFACTURING METHOD THEREOF**

Examiner: Douglas W. Owens

Group Art Unit: 2811

Assistant Commissioner for Patents
Washington, D.C. 20231

RECEIVED
FEB 24 2003
TECHNOLOGY CENTER 2800

AMENDMENT

SIR:

In response to the Office Action mailed on August 14, 2002, the period for responding thereto having been set to expire after November 14, 2002, the period for response not being extended for more than three months, please amend the above-captioned application as follows: